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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.: 09/781,616 Conf. No.: 9505  
Filing Date: 02/12/2001 Art Unit: 2141  
Applicant: Iwao Hatanaka Examiner: Lien, Tan  
Title: METHOD AND SYSTEM FOR Docket No.: CHA9-99-015 (IBMC-0105)  
AUTOMATED SESSION RESOURCE CLEAN-UP IN  
A DISTRIBUTED CLIENT-SERVER ENVIRONMENT

## COMMISSIONER FOR PATENTS

DESTINATION FACSIMILE NUMBER: 703-872-9306

Transmitted herewith is:

Request for Continued Examination – 1pg.  
Preliminary Amendment – 10 pgs.  
1 Month Petition for Extension of Time

in the above identified application.

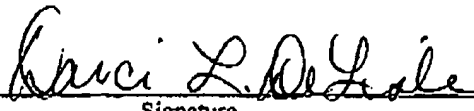
- ☒ The Commissioner is hereby authorized to charge and credit Deposit Account No. 09-0469 (IBM) as described below.
- ☒ Credit any overpayment.
- ☒ Charge any additional fee required including RCE Fee of \$790.00 and 1 month Extension of Time Fee of \$120.00.

  
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Michael F. Hoffman, Reg. No. 40, 019

DATE: April 19, 2005

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